

Electronic Acknowledgement Receipt

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Application Number:	10821438
Confirmation Number:	1354
Title of Invention:	Sidewall spacer for semiconductor device and fabrication method thereof
First Named Inventor:	Rong-Hui Kao
Customer Number:	47390
Filer:	Daniel R. McClure
Filer Authorized By:	
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Document Number	Document Description	File Name	File Size(Bytes)	Multi Part	Pages
1	Amendment - After Non-Final Rejection	00413256.pdf	158290	no	12

Warnings:	
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Total Files Size (in bytes):	158290
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